

Electronics Materials Information

Critical Materials Report: Electronic Gases 2016

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RESEARCH METHODOLOGY

TECHCET employs subject matter experts having firsthand experience within the industries, which they analyze. Most of TECHCET's analysts have over 25 years of direct and relevant experience in their field. Our analysts survey the commercial and technical staff of IC manufacturers and their suppliers, and conduct extensive research of literature and commerce statistics to ascertain the current and future market environment and global supply risks. Combining this data with TECHCET's proprietary, quantitative wafer forecast results in a viable long-term market forecast for a variety of process materials.



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